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Substitute for form 1449A/B/PTO				Complete If Known	
				Application Number	10/665,908-Conf. #7052
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date	September 18, 2003
				First Named Inventor	Demetrius Sarigiannis
				Art Unit	1762
				Examiner Name	K. M. Stouffer
Sheet	1	of	4	Attorney Docket Number	108298722US

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
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